**PATENT****IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

IN RE APPLICATION OF: Robert A. Weaver et al.

APPLICATION No.: 09/733,608

FILED: December 8, 2000

FOR: **METHOD AND APPARATUS FOR  
PROCESSING A MICROELECTRONIC  
WORKPIECE AT AN ELEVATED  
TEMPERATURE**

COPY OF PAPERS  
EXAMINER: Sikyin Ip ORIGINALLY FILED

ART UNIT: 1724

CONF. No: 4198

**RECEIVED**  
SEP 12 2002  
**TC 1700**

**Supplemental Information Disclosure Statement**  
**Under 37 CFR § 1.97(f)**

Assistant Commissioner for Patents

Washington, D.C. 20231

Sir:

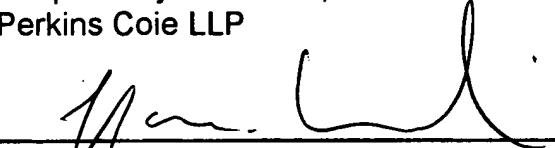
This is in response to the Office Communication mailed August 9, 2002.

On January 2, 2002, applicant mailed an Information Disclosure Statement to the USPTO, which included a modified Form PTO-1449 and copies of the cited references. The Examiner has requested resubmission of the International Search Report.

Accordingly, enclosed is Form PTO-1449 in compliance with 37 CFR 1.98, and a copy of the International Search Report.

Applicant believes no fee is due since it is clear that applicant made a bona fide attempt to comply with 37 CFR 1.98, and the lack of compliance was inadvertent (37 CFR 1.97(f)). Nonetheless, the Commissioner is hereby authorized to charge any necessary fee for acceptance of this request to Deposit Account No. 50-0665.

Respectfully submitted,  
Perkins Coie LLP

  
John M. Wechkin  
Registration No. 42,216

Date: Aug 29, 2002**Correspondence Address:**

Customer No. 25096  
Perkins Coie LLP  
Patent – SEA  
P.O. Box 1247  
Seattle, Washington 98111-1247  
(206)583-8888